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** CONTINUING DATA *****

This application is a 371 of PCT/JP04/10484 07/23/2004 /K.P./

** FOREIGN APPLICATIONS *****

JAPAN 2003-293904 08/15/2003 /K.P./

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **

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Foreign Priority claimed 35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 9	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 5
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ADDRESS

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TITLE

Method for forming film, method for manufacturing semiconductor device, semiconductor device and substrate treatment system

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